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Dated: December 13, 2004 Signature: \_\_\_\_\_

(Michael R. Gull)

Docket No.: 29936/39474  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Cha Deok Dong et al.

Application No.: 10/617,476

Confirmation No.: 3456

Filed: July 11, 2003

Art Unit: 2813

For: METHOD OF MANUFACTURING A  
SEMICONDUCTOR DEVICE

Examiner: Chandra P. Chaudhari

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the office action mailed on September 22, 2004, please amend the above-identified patent application as follows.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Abstract** begins on page 8 of this paper.

**Amendments to the Claims** and a complete listing of the claims begin on page 9 of this paper.

**Remarks** begin page 14 of this paper.